

## Publikationen

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- (2019): Cleaning effects in optical layers: error characteristics and analysis methods. In: Proceedings of SPIE 11171 (Sixth European Seminar on Precision Optics Manufacturing, 1117101 [9-10 April 2019, Teisnach]), Bellingham, WA, USA. DOI: 10.1117/12.2527974.
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- (2013): Analysis of three different measurement strategies carried out with the TII-3D coordinate measurement system. In: SPIE Optics + Photonics 2013, Optical Engineering + Applications. DOI: 10.1117/12.2024001.
- (2013): Calculation of the reference surface error by analyzing a multiple set of sub-measurements. In: SPIE Optics + Photonics 2013, Optical Manufacturing and Testing X, volume 8838. DOI: 10.1117/12.2024003.
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- (2012): Projekt 3P-Fertig. Posterpräsentation. In: Internes Optikseminar der Forschungsgruppe Optik, Teisnach.
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